

<b>Notice of References Cited</b>	Application/Control No. 10/605,233	Applicant(s)/Patent Under Reexamination LIN, HUI-CHU	
	Examiner Stanetta D. Isaac	Art Unit 2812	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,940,732	08-1999	Zhang, Hongyong	438/640
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Stanley Wolf and Richard N. Tauber, Silicon Processing For The VLSI Era, Second Edition, pgs. 170-180 and pgs. 202-206
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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